

Application/Control No.	Applicant(s)/Patent under Reexamination
10/790,997	DAVIES, CHRISTOPHER JOHN
Examiner	Art Unit
Michael A. Friedhofer	2832

SEARCHED				
Class	Subclass	Date	Examiner	
200	5qr,51.05, 51.06, 51.11, 51.12	9/15/2005	MAF	
324	114,133	9/15/2005	MAF	
324	156,424	9/15/2005	MAF	
324	508,509	9/15/2005	MAF	
324	522,555	9/15/2005	MAF	
324	556	9/15/2005	MAF	
340	649,650	9/15/2005	MAF	
340	654,656	9/15/2005	MAF	
439	651	9/15/2005	MAF	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
200	51r,51.11	9/15/2005	MAF	
200	51.12	9/15/2005	MAF	
340	650	9/15/2005	MAF	
324/508,509,555,556		9/15/2005	, MAF	

(INCLUDING SEARCH	STRATEGY	)
	DATE	EXMR
interference search: see search history	9/15/2005	MAF
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